

ONYX® 4" Ultra High Vacuum, IC Target, Standard Magnetics

US Specifications

Construction					
	Anode		304 Stainless Steel		
	Cathode Body		OFHC Copper		
	Insulator		Aluminum Oxide (Al ₂ O ₃)		
С	ooling Requireme	ents			
	Flow Rate at Ma	ximum Power	0.75 GPM		
	Maximum Input	Pressure, Open Drain	60 psi		
	Maximum Input	Temperature	68 °F		
D	imensions				
	A	8.000"			
	В	Consult Factory			

B Consult Factory C Consult Factory

General

	Magnetic Enhancement	Permanent (NdFeB) Encapsulated			
	Maximum Temperature, Magnets Demounted	842 °F			
	Maximum Temperature, Magnets Mounted	212 °F			
	Source to Substrate Distance	2.000" - 12.000"			
	Weight, Approximate Without Options	Consult Factory			
Maximum Sputtering Power *					
	Cathode Voltage	100 - 1500 Volts			
	Discharge Current	0.1 - 3 Amps			
	Indirect Cooled Mode, DC	1.5 kW			
	Indirect Cooled Mode, RF	500 Watts			
	Operating Pressure	2 - 50 mTorr			

Mounting, Standard

CF Flange	8.000"
Power Connector, DC	Type HN Connector, External Threads
Power Connector, RF	Type HN Connector, External Threads
Water, Outer Dimension Tubing	0.375"

Target

Cooling	Indirect
Diameter	4.000"
Form	Circular / Planar
Thickness	0.250"

Specifications Disclaimer

- All Angstrom Sciences NdFeB magnets are totally encapsulated and protected from degradation by water.
- All sources are available in external configurations.
- * Maximum power for cathode only, a target material's properties, such as, thermal and electrical conductivity may limit the maximum process power level.
- Some custom-engineered and specialty magnetrons may not meet standard specifications.
- Specifications are subject to change without notice.
- Typical performance. Results may vary with process parameters such as pressure, flow rate, target material, and substrate rotation, etc.

Please contact us for specifications regarding your application.

Angstrom Sciences | Call +1-412-469-8466 | www.angstromsciences.com